## 10/544246 > JC09 Rec'd PCT/PTO 02 AUG 2005

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				38484			TBD		
	INFC	RMATION DISCL BY APPLI	OSURE CITATION CANT		APPLICANT: Takeshi Kanazawa et al.						
		(USE SEVERAL SHEETS IF NECESSARY)			1				GROUP ART UNIT: TBD		
	<del></del>		U.S. PAT	ENT DOCUME	NTS						
Examiner Initial		Document No.	Date	Name		Class		Subclass		S Filing Date If Appropriate	
	A							ļ			
	В							-			
<del></del>	С			<del>-</del>		···	· · · · · ·	ļ			
	D						· -				
	E					-+		╁			
<del>-</del>	1		FOREIGN I	PATENT DOCUM	MENTS	<del></del>		L		<u> </u>	
<del></del> -	Document No		Date	Country	Clas		Sul	Subclass		Translation	
	a	11-88343	03/1999	JAPAN					Ciu	ed on ISR	
	Н	200 78158	03/2000	JAPAN			1		Cit	od on ISR	
	1	2002-241321	12/2000	IADAN					Cit	ed on ISR	
/K.C./	J	2002-185459	06/2002	JAPAN						Cited in Specification/ English Abstract	
	K	2002-237841	08/2002	JAPAN					Cit	ed on ISK	
	i	2002-300197	10/2002	JAPAN -					Cit	ed on ISR	
	īvi	2003-46333	02/2003	JAPAN					Сн	ed on ISR	
		OTHER REFERE	ENCES (Incli	uding Author, Title,	Date, F	Pertiner	t Page	s, Etc.	.)		
	N	Yasuhiko Matsuna Giho, NEC Corp.,	ga et al "Ko Vol 54, No. 8	osoku Access-Kei 3, pgs. 18-21, 08/20	Edgeno 001, pag	de-Yo.l ge 20, le	P Flow ft colu	v Seig mn, li	ine 10	to 20, Fig.	
	0	Norio Matsuko et a	al., "Polishing	-tsuki Yusendo Qu	eue (PP	PQ) Hos	hiki ni	yoru	Qos Ho	osho Kano	
		Na Duta Sachi" Th		Electronics, Inform		od Com	munica	tion F	inginee	set innen	
		Kenkyu Hokoku, I	E 2001-152,	12/2001, Dai 3 Sho	=						
	P	Kenkyu Hokoku, I	et al ."Ta Flo	w Shuyo o Jitsuge	n suru T	aiiki Se	igyo H	loshik	і по Те	ian". 2003	
	P	Kenkyu Hokoku, I	et al _"Ta Flo	Shuyo o litsuge , Information and C	n suru T Commur	aiiki Se	igyo H Engin	loshik eers S	i no Te Sogo Ta	ian" 2003 iikai Koen	